

# Tamper-Sensing Meshes in the Wild

**Jan Sebastian Götte & Björn Scheuermann**  
TU Darmstadt  
contact: [research@jaseg.de](mailto:research@jaseg.de)

2026-06-04

# What is a Tamper Sensing Mesh?

- ▶ Embedded looped conductor covering a surface
- ▶ Detects physical intrusion
  - ▶ Drills, saws, lasers etc.
- ▶ Triggers some tamper response
  - ▶ Deleting keys
  - ▶ Raising alarms
  - ▶ Explosions?
- ▶ Widely used in HSMs, payment terminals, ATMs, nuclear weapons

# The History of Tamper-Sensing Meshes

- ▶ **1870:** First patents using literal wire meshes to protect bank vaults [1, 2]
- ▶ **1902:** Multi-layer, orthogonal meshes documented [3]
- ▶ **1971:** Printed circuit technology adopted [4]
- ▶ **1990s:** Widespread commercial adoption with cryptographic applications

Other, hard to date examples: NSA use for protecting ciphering machines [5, 6], US use in nuclear weapons [7]

# Commercial Applications Today

- ▶ Datacenter HSMs (Key management, payment processing)
- ▶ Card Payment Terminals (PIN encryption)
- ▶ ATM Encrypting Pin Pads (PIN encryption)
- ▶ Key Safes for Emergency services access (Germany only?)
- ▶ Mail Franking Machines (credit counter)
- ▶ Slot Machines (likely for DRM)

# Our Survey

**Sample Size:** 30 devices

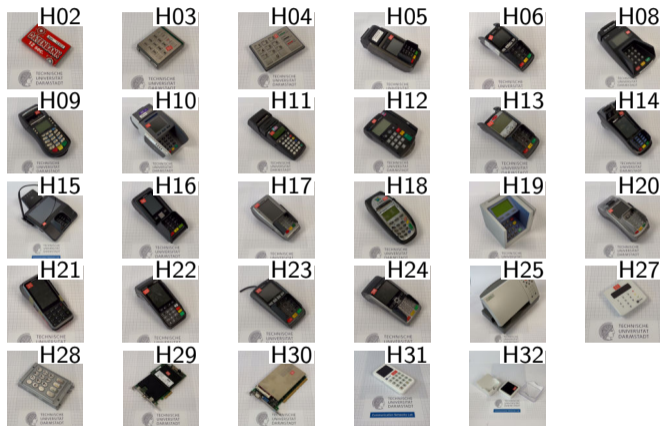
**Device Types:**

- ▶ 23 Card payment terminals (Verifone, Ingenico, SumUp, etc.)
- ▶ 3 ATM Encrypting Pin Pads (NCR, Sagem)
- ▶ 2 HSM modules (SafeNet, Utimaco)
- ▶ 1 Franking machine
- ▶ 1 German slot machine CPU

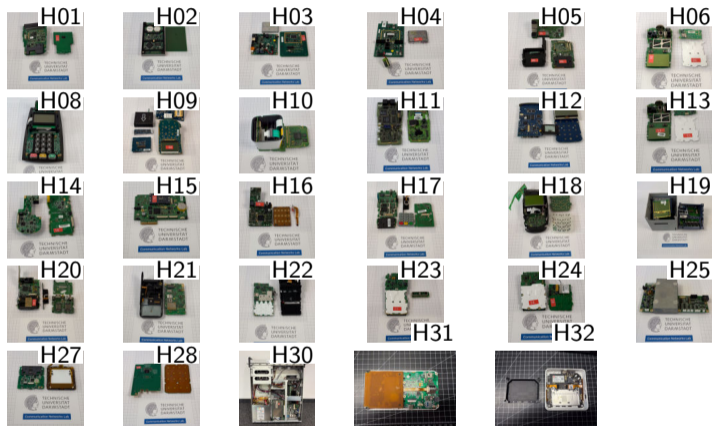
## Mesh Materials and Structure Sizes Observed

- ▶ **Rigid PCB (FR-4):** Photolithographic etching, 100  $\mu\text{m}$  to 200  $\mu\text{m}$
- ▶ **Polyimide/Copper FPC:** Photolithographic etching, 100  $\mu\text{m}$  to 200  $\mu\text{m}$
- ▶ **Silver ink FPC:** Screen printing, 500  $\mu\text{m}$  to 3000  $\mu\text{m}$
- ▶ **Carbon ink FPC:** Screen printing, 500  $\mu\text{m}$  to 3000  $\mu\text{m}$
- ▶ **Gold laser direct structuring:** Laser Direct Structuring, 50  $\mu\text{m}$  to 200  $\mu\text{m}$
- ▶ **IBM/Gore mesh:** Printed, 200  $\mu\text{m}$  to 1500  $\mu\text{m}$

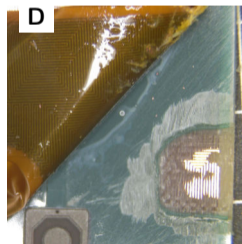
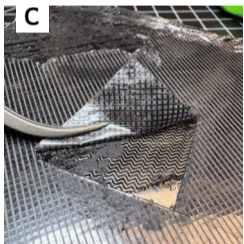
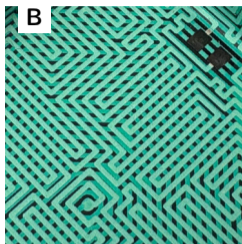
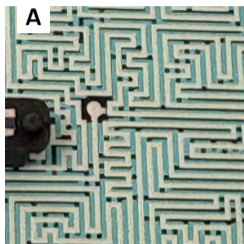
# Survey Specimens - External Photos



# Survey Specimens - Internal Photos

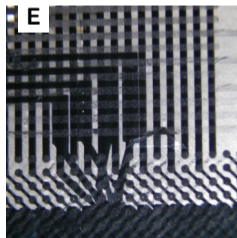
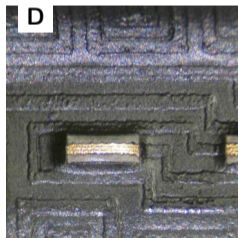
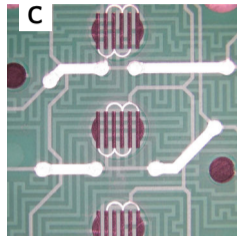
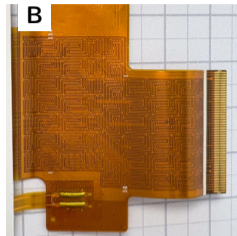
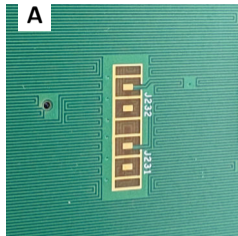


# Mesh Trace Layouts



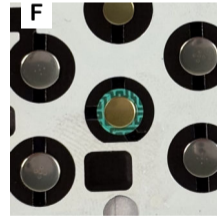
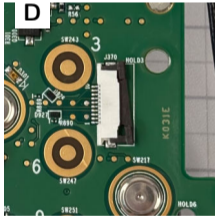
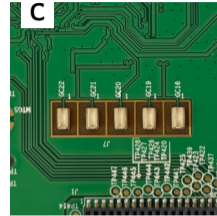
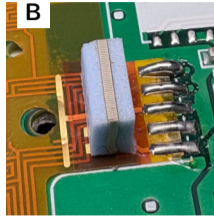
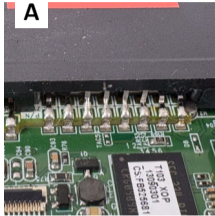
- A: Offset layers (H12)
- B: Orthogonal patterns (H14)
- C: Orthogonal + area pattern (H30)
- D: Spaced layers (H28)

# Mesh Materials and Manufacturing



- A: Rigid PCB (H10)
- B: Flexible PCB (H15)
- C: Silver ink (H14)
- D: Laser Direct Structuring (H32)
- E: Carbon ink (H30)

# Mesh Connection Methods



**A:** Direct soldering (H05)

**D:** FPC connector (H20)

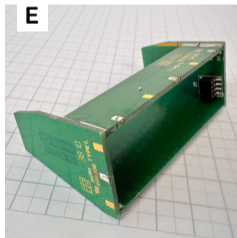
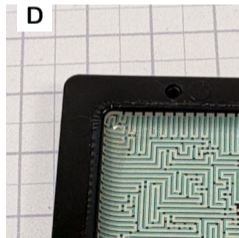
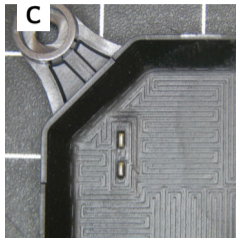
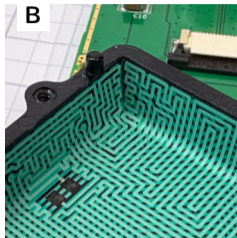
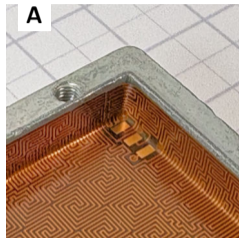
**B:** Elastomeric connector (H31)

**E:** Stacking connector (H17)

**C:** EMI gasket (H14)

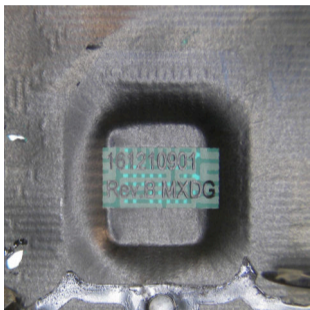
**F:** Tactile dome (H06)

# 3D Mesh Construction Styles

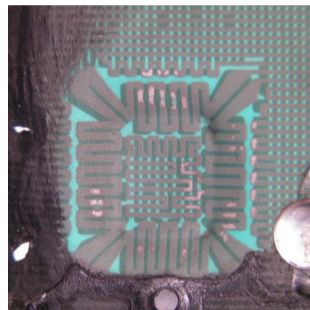


- A: Folded with overlap (H03)
- B: Folded without overlap (H14)
- C: Laser Direct Structuring (H32)
- D: Thermoformed (H12)
- E: House-of-Cards (H08)

# Thermoforming Example



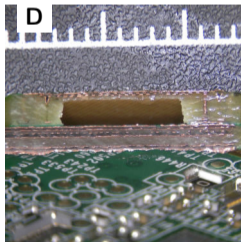
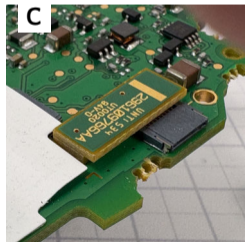
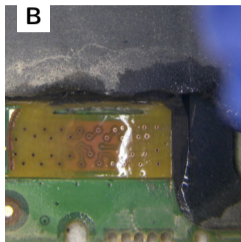
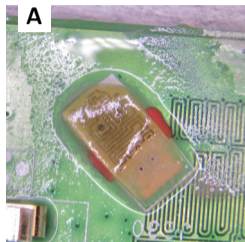
Before removing lacquer



After removing lacquer

Formed cavities in printed foil mesh specimen H24

# Sandwich-Style Construction



- A: Obstacle mesh coupons (H17)
- B: Via-fence meshes (H24)
- C: Planar sandwich stack (H24)
- D: PCB lid with cavity (H14)

## Security Issues Observed

- ▶ Incomplete mesh coverage
- ▶ Meshes not overlapping at edges leaving gaps for probe insertion
- ▶ Gaps at mesh-PCB interfaces
- ▶ Thermoformed cavities with enlarged structure size at corners
- ▶ In one case, an opaque lacquer was easily removed with acetone (without damaging the mesh!)
- ▶ Trace patterns visible through cover layers due to surface unevenness

## Design Recommendations (1/2)

- ▶ Commodity PCB manufacturing process design rules in the 100  $\mu\text{m}$  to 200  $\mu\text{m}$  range are better than the state of the art in mesh structure size
- ▶ Avoid ink printing processes or thermoforming because of their large structure size
- ▶ Carefully think about your literal corner cases (and edges)!
  - ▶ Overlap meshes where possible.
- ▶ Use potting and cover layers, but verify that they work
  - ▶ Check that you *actually* can't see what's below
  - ▶ Test their chemical resistance (and that of your mesh)

## Design Recommendations (2/2)

- ▶ Mixing tough potting or enclosure materials and fragile mesh materials makes life harder for an attacker
  - ▶ Consider using steel instead of plastic (also helps against X-ray inspection!)
  - ▶ Use thin substrates and thin conductive layers for the mesh
  - ▶ Balance adhesion so removing potting / cover layers tears away traces below
- ▶ Overlap mesh layers at a 50% structure size offset
- ▶ Space (some) mesh layers apart in Z direction to constrain attack tools
- ▶ Use a pressure-sensitive connection method like tactile domes or elastomeric connectors

# Thank you!

Questions?

research@jaseg.de

## Specimen List (1/2)

ID	Device	Manufacturer	Type	Year
H01	PED	Verifone	VX 570	ca. 2010
H02	Slot machine	Merkur / ADP	Sam 12 EC2	ca. 2012
H03	EPP	Sagem	USA1315-4240	2014
H04	EPP	Sagem	USA1316-5120	2007
H05	PED	Xac	xAPT-103	2014
H06	PED	Ingenico	iCT250-11T1860A	2016-17
H08	PED	Sagem	NOR4100-4220	2012
H09	PED	Hypercom	M4230	2010
H10	PED	Worldline	YOMANI XR	2016
H11	PED	Banksys	C-ZAM Smash	2004
H12	PED	Hypercom	Optimum P2100	2010
H13	PED	Ingenico	iCT 220-11T2938A	2016
H14	PED	Verifone	H5000	2016
H15	PED	Verifone	MX 925	2018
H16	PED	Verifone	V200c CTLS	2021
H17	PED	Verifone	VX 680	2014

## Specimen List (2/2)

ID	Device	Manufacturer	Type	Year
H18	PED	Ingenico	i7910	2010
H19	PED	Banksys	XENTA	2004-2011
H20	PED	Verifone	VX 520 3G	2017
H21	PED	Verifone	V400m Plus 4G	2018
H22	PED	Ingenico	Move 3500	2020
H23	PED	Ingenico	iPP 350-11T1718A	2015
H24	PED	Ingenico	iWL255-01T2117A	2016
H25	Franking Mach.	Neopost	IJ-25	ca. 2001
H27	PED	Sumup	AIR1E205	2021
H28	EPP	NCR	5814 UEPP	2019
H29	HSM	SafeNet	VBD-05	2018
H30	HSM	Irdeto	Mayflower	2011
H31	PED	SumUp	SumUp 3G	2019
H32	PED	SumUp	SumUp Air	2022

PED: Pin Entry Device; EPP: Encrypting Pin Pad; HSM: Hardware Security Module

# References I

- [1] “Improvement in Protecting Safes and Vaults from Burglars”. U.S. pat. 106324A. Aug. 16, 1870. URL: [https://patents.google.com/patent/US106324A/en?q=\(G08B13%2f126\)&oq=\(G08B13%2f126\)&sort=old](https://patents.google.com/patent/US106324A/en?q=(G08B13%2f126)&oq=(G08B13%2f126)&sort=old) (visited on 09/10/2025).
- [2] “Improvement in Electro-Magnetic Envelopes for Safes, Vaults”. U.S. pat. 110362A. Dec. 20, 1870. URL: [https://patents.google.com/patent/US110362A/en?q=\(G08B13%2f126\)&oq=\(G08B13%2f126\)&sort=old](https://patents.google.com/patent/US110362A/en?q=(G08B13%2f126)&oq=(G08B13%2f126)&sort=old) (visited on 09/10/2025).
- [3] Henry M. Sutton, Walter L. Steele, and Michael Coerver. “Electrically-Protected Structure”. U.S. pat. 708093A. Individual. Sept. 2, 1902. URL: <https://patents.google.com/patent/US708093A/en?q=US708093> (visited on 09/10/2025).

## References II

- [4] Conrad S. Ham and Elwood R. Horwinski. "Printed-Circuit Type Security Apparatus for Protecting Areas". U.S. pat. 3594770A. Lewis Engineering Co. July 20, 1971. URL: [https://patents.google.com/patent/US3594770A/en?q=\(H01L23%2f576\)&oq=\(H01L23%2f576\)&sort=old&page=2](https://patents.google.com/patent/US3594770A/en?q=(H01L23%2f576)&oq=(H01L23%2f576)&sort=old&page=2) (visited on 09/10/2025).
- [5] David G. Boak. *A History of U.S. Communications Security (The David G. Boak Lectures), Volume I.* (US) National Security Agency, 1973. URL: [http://archive.org/details/history\\_comsec-nsa](http://archive.org/details/history_comsec-nsa) (visited on 02/18/2025).
- [6] David G. Boak. *A History of U.S. Communications Security (The David G. Boak Lectures), Volume II.* (US) National Security Agency, 1981. URL: [http://archive.org/details/history\\_comsec\\_ii-nsa](http://archive.org/details/history_comsec_ii-nsa) (visited on 02/18/2025).
- [7] Ashton Carter et al., eds. *Managing Nuclear Operations.* Washington, D.C: Brookings Institution, 1987. 751 pp. ISBN: 978-0-8157-1313-5 978-0-8157-1314-2.